

Docket Number: 071469-0305396

PATENT APPLICATION

Client Reference: PC8014A

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of

GORDON BEASE, et-al.

Group Art Unit: 1763

Application No.: 10/644,957

Examiner: Unassigned

Filed: August 21, 2003

Confirmation No.: 7598

For: METHOD AND SYSTEM TO ENHANCE THE REMOVAL OF HIGH-K
DIELECTRIC MATERIALS

SECOND INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

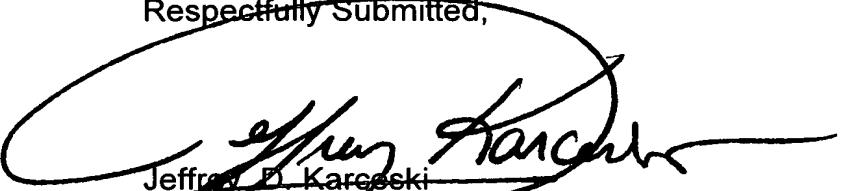
Sir:

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom. Applicants respectfully request the Examiner return an initialed copy of the enclosed Form PTO-1449 to Applicants with the next Office communication to indicate that the reference(s) has been considered, per MPEP § 609.

This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of the first Office Action on the merits in the present application. No certification or fee is required.

The reference(s) was/were cited in a counterpart foreign application. A copy of the International Search Report is attached for the Examiner's information.

Respectfully Submitted,



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FORM PTO-1449 (modified)
 To: U.S. Department of Commerce
 (PW FORM PAT-1449)
 Patent and Trademark Office



**INFORMATION DISCLOSURE STATEMENT
BY APPLICANT**

Date: May 6, 2004

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Atty. Dkt. No.	M#	Client Ref.
	071469-0305396	PC8014A2
Applicant: Bease et al.		
Appln. No.: 10/644,957		
Filing Date: August 21, 2003		
Examiner: Unassigned		Group Art Unit: 1763

U.S. PATENT DOCUMENTS

Examiner's Initials*	Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
AR	6258608	07/2001	Jung			
BR	4940509	07/1990	Tso et al.			
CR	4690728	09/1987	Tsang et al.			
DR	US20020043340	04/2002	Kojima et al.			
ER	US20030104706	06/2003	Mitsuhashi et al.			
FR						
GR						
HR						
IR						
JR						
KR						
LR						
MR						
NR						

FOREIGN PATENT DOCUMENTS

	Document Number	Date MM/YYYY	Country	Inventor Name	English Abstract		Translation Readily Available	
					Enclosed	No	Enclose	No
OR								
PR								
QR								
RR								
SR								
TR								
UR								

OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)

VR	Thomas et al., "A Practical PZT Dry Etching Process That Increases the Top Electrode Contact Reliability in Pyroelectric Detector Arrays by Using a MORI High Density Plasma System," 2001 IEEE/SEMI Advanced Semiconductor Manufacturing Conference, pp 81-83.		
WR	International Search Report from PCT/US03/26496, dated April 14, 2004, which is related to the instant application.		
XR			
YR			
ZR			
AAR			

Examiner

Date Considered:

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.